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PATENT APPLICATION 2621

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Michael J. Sailor and

Shawn O. Meade

Serial No.:

10/589,741

Conf. No.:

9856

Filed:

August 16, 2006

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Art Unit:

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Examiner:

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Attorney for Applicant(s) 32 Registration No. 35/32

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- (b) before the mailing date of First Office Action on the merits (i.e., not including actions such as restriction requirements); or
- (c) before the mailing of a First Office Action after the filing of a Request for Continuing Examination.

Applicant(s) submit herewith Form PTO-1449 (Information Disclosure Citation) together with copies of foreign patents, publications or other information of which applicant(s) are aware, which applicant(s) believe may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. Applicant(s) respectfully submit that the citation of any reference on Form PTO-1449 does not constitute an admission that the reference qualifies as prior art.

It is requested that the information disclosed on the enclosed Form PTO-1449 be made of record in this application.

The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R.§§1.16-1.17, or to credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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| Application Number | 10/589,741 | | | |
| Filing Date | 8/16/2006 | | | |
| First Named Inventor | Michael J. Sailor | | | |
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| Attorney Docket Number | 0321.68812 | | | |

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First Named Inventor Michael J. Sailor

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Examiner Name

Sheet 2

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| Examiner | Cite No.1 | Document Number | Publication Date | Name of Patentee or | Pages, Columns, Lines, Where Relevant Passages or Relevant |
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| Sheet 3 of 6 | Attorney Docket Number | 0321.68812 |

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| INFORMATION DISCLOSURE | First Named Inventor | Michael J. Sailor |
| STATEMENT BY APPLICANT | Art Unit | |
| | Examiner Name | |
| Sheet 5 of 6 | Attorney Docket Number | 0321.68812 |

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